

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	KIM, Hyun-Jae and KANG, Myung-Koo		
Assignee:	SAMSUNG ELECTRONICS CO., LTD.		
Title:	METHOD OF POLYCRYSTALLIZATION, METHOD OF MANUFACTURING POLYSILICON THIN FILM TRANSISTOR, AND LASER IRRADIATION DEVICE THEREFOR		
Int'l. Application No.:	PCT/KR2003/002212	Int'l. Filing Date:	10/21/2003
Application No.:	Not Assigned	Filing Date:	Herewith
Examiner:	Not Assigned	Group Art Unit:	Not Assigned
Docket No.:	AB-1432 US		

San Jose, California
April 22, 2005

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above-identified application. Copies of the documents are enclosed with the exception of any U.S. patents. The documents were cited by the Korean Patent Office in the International Search Report for International Application No. PCT/KR2003/002212, which is the international stage of the present application

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or

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3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

No fee is believed to be required. If a fee is required for this Information Disclosure Statement, please charge the fee to Deposit Account No. 50-2257. This paper is submitted in duplicate.

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Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office		Atty. Docket No.	Application No.
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s)	
(Use several sheets if necessary)		KIM, Hyun-Jae and KANG, Myung-Koo	
		Filing Date	Group
		Herewith	Not Assigned

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	US 5,302,230	04/12/1994	Ino et al.			
	AB	US 2001/0019863	09/06/2001	Yang			
	AC	US 2002/0083557	07/04/2002	Jung			
	AD	US 2002/0110962	08/15/2002	Wada et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

							Translation
		Document	Date	Country	Class	Subclass	Yes
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	Patent Abstracts of Japan, Publication No. 54-153745, 12/04/1979, 1 page
	AR	Patent Abstracts of Japan, Publication No. 56-047288, 04/28/1981
	AS	Patent Abstracts of Japan, Publication No. 60-247488, 12/07/1985

Examiner Date Considered

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	AP								

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	Patent Abstracts of Japan, Publication No. 01-214011, 08/28/1989
	AR	Patent Abstracts of Japan, Publication No. 02-165880, 06/26/1990
	AS	Patent Abstracts of Japan, Publication No. 03-235040, 10/21/1991

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